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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10043096	FILING DATE 01/14/2002	CLASS 361 029	SUBCLASS 234	GAU 3720	EXAMINER HARRIS, Anton
**APPLICANTS: Lee Sun-Young; 2836 2831					
**CONTINUING DATA VERIFIED: OK					
** FOREIGN APPLICATIONS VERIFIED: OK REPUBLIC OF KOREA 2001-29656 05/29/2001					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO			
35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		242/115			
Verified and Acknowledged Examiners's initials ASH					
TITLE : Wafer space supporting apparatus installed on electrostatic chuck and method for fabricating the same					

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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